

Substitute for form 1449A/PTB

PTO/SB/08a (08-03)

Approved for use through 07/31/2006. OMB 0651-0031

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Complete if Known

Application Number	10/802,618
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Filing Date	March 17, 2004
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First Named Inventor	Staecker, et al.
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Art Unit	2812
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Examiner Name	Unknown
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Attorney Docket Number	2003 P 50524 US
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Sheet	1	of	2
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U.S. PATENT DOCUMENTS

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FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ - Number ⁴ - Kind Code ⁵ (if known)				
HAI	F	WO 02/067055 A2	08-29-2002	Board of Regents, The University of Texas System		
HAI	G	WO 2004/013693 A2	02-12-2004	Molecular Imprints, Inc.	p. 1, pp. 10-12, pp. 40-47	

Examiner Signature	/Anthony Nguyen/	Date Considered	04/27/2006
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Substitute for form 1449B/PTO

(Use as many sheets as necessary)

Sheet

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of

2

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10/802,618

Filing Date

March 17, 2004

First Named Inventor

Staecker, et al.

Art Unit

2812

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Unknown

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2003 P 50524 US

NON PATENT LITERATURE DOCUMENTS

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Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.

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WHITE, D.L., *et al.*, "Novel Alignment System for Imprint Lithography," J. Vac. Sci. Technol. B Vol. 18, No. 6, Nov/Dec 2000, pp. 3552-3556.

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DENG, Y., *et al.*, "Simulation of Exposure and Alignment for Nano-imprint Lithography," Proceedings of the SPIE, The International Society for Optical Engineering, USA, 2002, Vol. 4688, No. 1-2, pp. 842-849

**Examiner
Signature**

/Anthony Nguyen/

Date Considered

04/27/2006

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